

Modeling Hydrogen Permeation through a Thin TiO₂ Film Deposited on Pd Using COMSOL Multiphysics

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Abstract: Models that describe hydrogen permeation through a thin TiO₂ film deposited on Pd have been developed based on a mass-balance equation consisting of diffusion, reversible hydrogen absorption/desorption, and irreversible hydrogen trapping. These models are solved by the finite element method using COMSOL Multiphysics. By comparing model simulations with experimental permeation curves, values of the parameters associated with permeation, such as diffusion coefficients, absorption and desorption rate constants, trapping rate constants, and saturation concentrations can be evaluated. These values are required to develop models to predict hydrogen-induced cracking in oxide-covered Ti-alloys.

Keywords: hydrogen permeation, titanium oxide, palladium, thin film, model simulation

1. Introduction

Titanium and its alloys have many industrial applications thanks to their excellent corrosion resistance and high specific strength. However, they are potentially susceptible to hydrogen-induced cracking (HIC) as a consequence of hydrogen absorption.^[1] Hydrogen absorbed into Ti-alloys results in the formation of hydrides and fast crack growth which ultimately could lead to failure. Generally, titanium is covered by a passive titanium oxide (TiO₂) film. Though very thin (usually a few nanometers), this compact film acts not only as a protective layer against corrosion but also as a barrier to hydrogen absorption into the metal. The impermeability of this film is, therefore, the limiting feature preventing HIC in Ti-alloys.

Hydrogen permeation through TiO₂ films is a complex process involving interfacial charge transfer, adsorption, absorption, trapping, and transport, and, thus, is inherently influenced by properties of the oxide, such as the chemical composition and structure, the presence of Tiⁿ⁺ interstitials and/or oxygen vacancies, the type

and concentration of impurities, hydrogen solubility, the adsorption characteristics of the surface, and the oxide thickness, porosity and uniformity.^[2] The mechanism by which the oxide influences hydrogen permeation into Ti and its alloys is still not well established.

In aqueous solutions, measurable hydrogen absorption requires cathodic polarization leading to redox transformations within the oxide or the activation of “hydrogen windows” at defects in the film.^[3] Torresi et al.^[4] suggested that the activation energy for hydrogen evolution on passive titanium was much higher than on bare metal. Several studies^[5,6] have shown that diffusion of hydrogen in TiO₂ is much slower than in Ti metal. Thus, the retardation of hydrogen permeation by TiO₂ films may be due to a combination of low hydrogen absorption at the oxide surface and/or slow hydrogen transport in the oxide. In general, it is difficult to predict the rate of hydrogen transport through a TiO₂ film and how many hydrogen atoms, generated on the TiO₂ surface, reach the Ti substrate.

In this communication, we present models for hydrogen permeation through a thin TiO₂ film deposited on Pd. These models are solved by the finite element method (FEM) using COMSOL Multiphysics, and compared with experimental permeation measurements.

2. Experimental

Due to complications caused by the formation of hydrides in Ti metal, a thin TiO₂ film vacuum-deposited on a Pd foil was used. Pd was selected as the substrate because of its high solubility for hydrogen and rapid kinetics for hydrogen absorption and transport.^[7]

A Devanathan^[8] electrochemical cell was used to measure hydrogen permeation, Figure 1. The TiO₂/Pd electrode is in the form of a membrane separating cell into two compartments. Hydrogen is generated galvanostatically on the TiO₂/solution interface by water reduction, and a fraction of the

hydrogen atoms produced are absorbed into the oxide. The hydrogen atoms then permeate through the TiO_2/Pd membrane to be re-oxidized at the Pd/solution interface at a potential at which hydrogen oxidation is diffusion controlled. The anodic currents are measured as a function of time at the Pd/solution interface yielding permeation curves presented after normalizing to the charging currents.

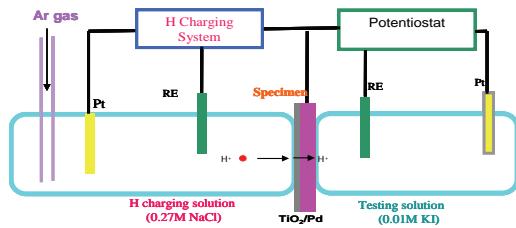


Figure 1. TiO_2/Pd electrode acting as a membrane separating the Devanathan cell into two compartments: the left side of the membrane is galvanostatically charged, and the right compartment is potentiostatically maintained at 0.18V_{SCE}.

3. Permeation Models

Figure 2 shows schematically the processes of hydrogen permeation through a thin TiO_2 film deposited on Pd. As shown, three processes are involved, namely, (a) hydrogen diffusion, (b) reversible hydrogen absorption/desorption, and (c) irreversible hydrogen trapping.

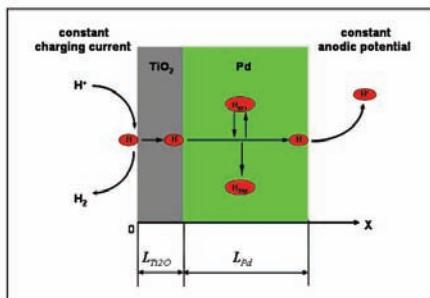


Figure 2. Schematic illustration of hydrogen permeation through a TiO_2/Pd system.

3.1 Pd Model

To investigate hydrogen permeation through oxide films on Pd, it is necessary first to clarify hydrogen permeation through Pd alone. Since the area of the Pd coupon is much greater than its thickness, a one-dimensional model is applicable. The mass balance equation accounting for the three processes is written as

$$\frac{\partial}{\partial t} C_D(x,t) = D \frac{\partial^2}{\partial x^2} C_D(x,t) - \frac{\partial}{\partial t} [C_A(x,t) + C_T(x,t)] \quad (1)$$

where C_D , C_A , and C_T are the concentrations of diffusible (free), absorbed (reversible), and trapped (irreversible) hydrogen in Pd, respectively, and D is the hydrogen diffusion coefficient. The first term on the right-hand side of Eqn (1) represents the change in the concentration as a result of diffusion, while the second represents the change due to hydrogen absorption and trapping.

The reversible absorption (hereafter referring simply as absorption) is a dynamic process in which hydrogen absorbs and desorbs. The rate equation is represented by a first-order reaction as

$$\frac{\partial}{\partial t} C_A(x,t) = k_A C_D(x,t) - k_D C_A(x,t) \quad (2)$$

where k_A and k_D are the rate constants for absorption and desorption, respectively. The trapping is an irreversible process, and its rate is assumed to be linearly proportional to the number of available trapping sites, *i.e.*

$$\frac{\partial}{\partial t} C_T(x,t) = k_T \left(1 - \frac{C_T(x,t)}{C_T^S} \right) C_D(x,t) \quad (3)$$

where k_T is the trapping rate constant, and C_T^S is the saturation concentration of trapped hydrogen.

The two surfaces of the Pd coupon are galvanostatically or potentiostatically controlled, yielding the boundary conditions,

$$-D \frac{\partial}{\partial x} C_D(x=0,t) = f_H \frac{i_0}{F} \quad (4)$$

$$C_D(x=L,t) = 0$$

where i_0 is the charging current density, f_H is the charging efficiency defined as the ratio of the

hydrogen produced to that absorbed by the oxide, F is the Faraday constant, and L is the thickness of the Pd coupon. Initially, the coupon is free of hydrogen, *i.e.*

$$C_D(x, t=0) = C_A(x, t=0) = C_T(x, t=0) = 0 \quad (5)$$

Once steady state is established, the charging current is turned off, and the hydrogen absorbed during charging begins to be released. During this discharge period, the mass balance is governed by

$$\frac{\partial}{\partial t} C_D(x, t) = D \frac{\partial^2}{\partial x^2} C_D(x, t) - [k_A C_D(x, t) - k_D C_A(x, t)] \quad (6)$$

Eqn (6) does not contain a trapping term because this process is irreversible, and does not occur after all available sites have been saturated. During a discharging period, the hydrogen will be released from both sides of the Pd coupon under the conditions,

$$C_D(x=0, t > t_0) = C_D(x=L, t > t_0) = 0 \quad (7)$$

where t_0 is the charging time.

3.2 TiO₂/Pd Model

For simulations depending on meshing, such as FEM, difficulties are often encountered in models containing thin layers since large geometric scale variations are present (in the present case 24nm:0.1mm). Three approaches have been attempted. The first approach used actual dimensions but different mesh densities in the TiO₂ and Pd. Simulations appeared to yield reasonable results on certain parameter values but not on others. The second approach used different length scales in the TiO₂ and Pd subdomains, with the diffusion and absorption parameters normalized accordingly. However, normalization of the flux is ambiguous at TiO₂/Pd interface. To overcome this difficulty due to the large differences in dimensions of the TiO₂ film and Pd, the thin-layer approximation was applied, in which the thin TiO₂ film is replaced by a boundary layer sandwiched between a hypothetical fast diffusion layer (FDL) and the Pd, as demonstrated in Figure 3.

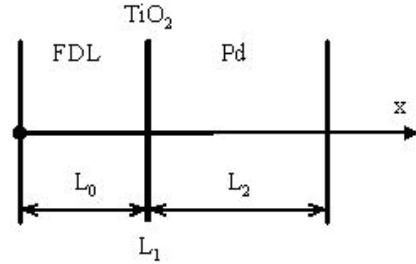


Figure 3.Schematic illustrating the sandwich model in which the TiO₂ film is represented as a boundary layer between a fast diffusion layer (FDL) and the Pd

The FDL is a hypothetical layer in which diffusion is so fast that it has a little effect on the subsequent TiO₂ and Pd, as given by

$$\frac{\partial}{\partial t} C_0(x, t) = D_0 \frac{\partial^2}{\partial x^2} C_0(x, t) \quad (D_0 \gg D_1, D_2) \quad (8)$$

Hereafter we use subscripts ‘0’, ‘1’ and ‘2’ referring to diffusional quantities in the FDL, TiO₂ and Pd, respectively.

Absorption and trapping are negligible in TiO₂ since it is very thin. Diffusion in TiO₂ is not explicitly treated, but incorporated as interior boundary conditions in the sandwich model. The flux at the interior boundary is approximated by the equation,

$$J_1(t) = -\frac{D_1}{L_1} (C_2(L_0^+, t) - C_0(L_0^-, t)) \quad (9)$$

where $C_0(L_0^-, t)$ and $C_2(L_0^+, t)$ are the concentrations at the left and right surfaces of the boundary layer, and D_1 and L_1 are the hydrogen diffusion coefficient and thickness of the TiO₂ layer, respectively. At the interior boundary the concentrations are discontinuous, and can be calculated using the assembly feature. A similar approach has been applied in modeling contact resistances between metals.^[9] The Pd is still governed by Eqns (1)–(3), and the boundary conditions at the entrance and exit are as stated in Eqn (4).

After charging for a period of time, a steady state is achieved at which all concentrations are time-independent. At steady state, these concentrations can be determined analytically as

$$\begin{aligned} C_0^{ss}(x) &= \frac{f_H i_0}{F \cdot D_0} (L_0 - x) + \frac{f_H i_0}{F} \left(\frac{L_1}{D_1} + \frac{L_2}{D_2} \right) \\ C_2^{ss}(x) &= \frac{f_H i_0}{F \cdot D_2} (L_0 + L_2 - x) \\ C_A^{ss}(x) &= \frac{k_A}{k_D} C_2^{ss}(x); \quad C_T^{ss}(x) = C_T \end{aligned} \quad (10)$$

where C_0^{ss} is the steady state hydrogen concentration in the FDL, and C_2^{ss} , C_A^{ss} , and C_T^{ss} are the steady state concentrations of diffusible, absorbed, and trapped hydrogen in Pd, respectively. Once steady state is established, the charging current is turned off. During a discharging period, though very thin, the TiO_2 film acts as a barrier that blocks hydrogen release from the TiO_2/Pd side. Therefore the boundary conditions during discharge are given by

$$\begin{aligned} D_1 \frac{\partial}{\partial x} C_1(x = L_0, t > t_0) &= 0 \\ C_2(x = L_0 + L_2, t > t_0) &= 0 \end{aligned} \quad (11)$$

4. Results and Discussion

The permeation models developed in Section 3 were simulated by COMSOL Multiphysics (Chemical Engineering Module, version 3.4), and compared with experimental permeation curves. This procedure was first applied to a Pd-only system to obtain the permeation parameters in Pd, and then extended to the TiO_2/Pd system to derive the parameters for the TiO_2 film. The values of simulation parameters are tabulated in the Appendix.

Figure 4 shows the permeation curves measured in Pd when charging at 80 nA/cm^2 . The curves show some features typically observed in transport-absorption processes.^[10] After a time lag, the permeation current increases, initially rapidly, before more slowly achieving the steady-state value from which the charging efficiency f_H can be calculated. Once the charging current is switched off, the permeation current drops, but not immediately back to a background value, with the tailing off as a consequence of the release of the hydrogen absorbed during charging.

The model simulation fits the experimental result well, indicating that the model is a reasonable description of the permeation process.

The diffusion coefficient obtained from the simulation, $3.34 \times 10^{-7} \text{ cm}^2/\text{s}$, is consistent with published values.^[7,11] No published data are available for comparison to the absorption/desorption rate constants, the trapping rate constant, and the trapping saturation in Pd. The ratio $k_A/k_D = 80$ indicates that the reversible absorption process is only slightly reversible, and may not be easily separable from the irreversible trapping process. The values of k_A and k_D were thus calculated from the discharging period where only reversible absorption is active. The values of k_T and C_T^{ss} indicate that the Pd specimens have a number of traps that strongly interact with hydrogen. One possible source for such traps is the cold-working of the Pd foils during fabrication.

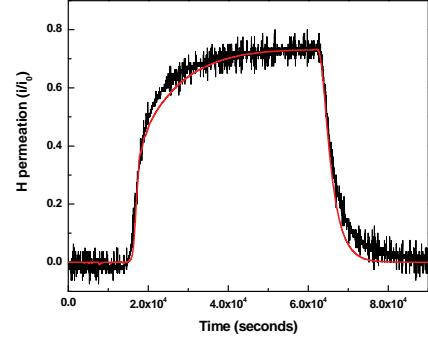


Figure 4. A model simulation (—) compared to an experimental permeation curve (—) obtained for Pd

The experimental and simulated permeation curves for TiO_2/Pd charging at 80 nA/cm^2 are shown in Figure 5. For Pd, the parameter values obtained for the Pd-only simulations were applied, on the assumption that the properties of the Pd are uninfluenced by the TiO_2 layer. The model simulation reproduces the experimental permeation curve over the charging period, but a notable discrepancy is observed over the discharge period. During discharge, the TiO_2 film acts as a barrier to hydrogen release, allowing hydrogen release only from one side (c.f. Eqns (7) and (11)). Hence, discharge would be expected to be slower for TiO_2 -covered Pd than for bare Pd. The observed steep decrease without tailing cannot presently be explained, and requires further investigation.

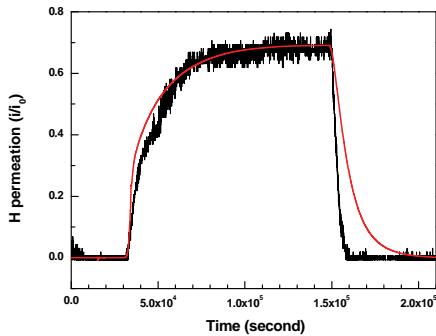


Figure 5. A model simulation (—) compared to an experimental permeation curve (—) for TiO₂ deposited on Pd

Comparison to the Pd-only system shows that the TiO₂ film noticeably impedes hydrogen permeation. The charging efficiency for TiO₂/Pd (0.6935) is smaller than that for Pd (0.7325), indicating that a smaller fraction of the hydrogen produced on a TiO₂ surface is absorbed compared to that absorbed on a bare Pd surface. However, the most remarkable effect is in the times required for permeation currents to start rising and to achieve the steady state, which are doubled for TiO₂/Pd compared to Pd. This could suggest that hydrogen transport through the oxide rather than hydrogen evolution at the oxide surface is responsible for the strong retardation of TiO₂ films on hydrogen permeation.

The hydrogen diffusion coefficient in TiO₂ films, D_I , is one of the most important parameters in predicting HIC in Ti-alloys. The value of D_I obtained in this study (10^{-13} cm²/s) is three orders of magnitude lower than that in Ti metal,^[12] and close to that found by Pyun et al.^[5] ($(3.9\text{--}5.2)\times10^{-14}$ cm²/s), but higher than that obtained by Pound^[4] (7.5×10^{-20} cm²/s) in TiO₂. The D_I calculated by the present models can be regarded as an apparent or effective diffusion coefficient, which includes the influence of absorption and trapping in the oxide.

Figure 6 shows the simulation results for various values of D_I , and demonstrates that hydrogen permeation is very sensitive to hydrogen diffusion in the oxide. The slower the diffusion through TiO₂, the longer the time-lag before permeation commences, and the longer the time required to achieve steady state. Figure

6 also confirms that 10^{-13} cm²/s is an optimized value in fitting the experimental data.

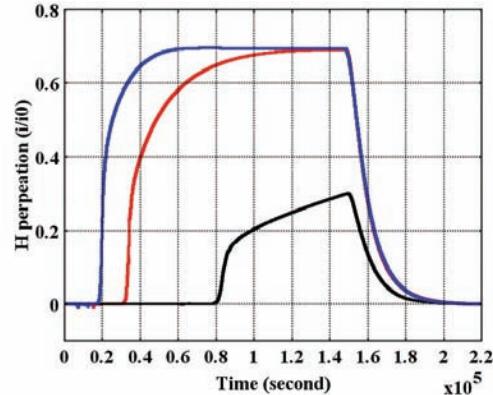


Figure 6. Effect of diffusion in TiO₂ on permeation curves: (—) $D_I = 10^{-16}$ m²/s, (—) $D_I = 10^{-17}$ m²/s, (—) $D_I = 10^{-18}$ m²/s (other simulation parameters are shown in Table 1)

5. Conclusions

Models describing hydrogen permeation through a thin TiO₂ film deposited on Pd were developed and solved using COMSOL Multiphysics. Comparison of simulated and experimental permeation curves shows the models provide a better understanding of the mechanistic details of hydrogen absorption by oxide-covered Ti and yields values of the permeation parameters required to predict HIC in Ti-alloys. While focused specifically on the TiO₂/Pd system, the models can be readily adapted to other material systems.

6. References

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7. Acknowledgements

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8. Appendix

Table 1: Values of simulation parameters

	Value	Description
i ₀	8 x10 ⁻⁴ A/m ²	charging current density
f _H	0.6935	charging efficiency
t ₀	149000 s	charging time
L ₀	1 x10 ⁻⁵ m	FDL thickness
L ₁	2.4 x10 ⁻⁸ m	TiO ₂ thickness
L ₂	0.0001 m	Pd thickness
D ₀	1 x10 ⁻⁵ m ² /s	diffusion coefficient in FDL
D ₁	1 x10 ⁻¹⁷ m ² /s	diffusion coefficient in TiO ₂
D ₂	3.34 x10 ⁻¹¹ m ² /s	diffusion coefficient in Pd
k _A	1 s ⁻¹	absorption rate constant in Pd
k _D	0.0125 s ⁻¹	desorption rate constant in Pd
k _T	10 s ⁻¹	trapping rate constant in Pd
C _T ^S	0.58 mol/m ³	trapping saturation in Pd